

10/637108 Examiner: LEBENTRITT, MICHAEL GAU: 2824
Classification: 438/685.000 Inventor: SANDHU , GURTEJ, et al
Status: 80 - RESPONSE AFTER FINAL ACTION FORWARDED TO EXAMINER
Title: LOW-RESISTANCE CONTACT TO SILICON HAVING A TITANIUM SILICIDE INTERFACE AND AN AMORPHO...

Bib Data report

Application Title:LOW-RESISTANCE CONTACT TO SILICON HAVING A TITANIUM SILICIDE INTERFACE AND AN AMORPHOUS TITANIUM CARBONITRIDE BARRIER LAYER

Application Num:  (in phx) 10637108 **Filing Date:**08/08/2003

Effective Filing:08/08/2003

(Location History) (Foreign/Continuity Data)

Status: 80/RESPONSE AFTER FINAL ACTION FORWARDED TO EXAMINER

Status Date: 08/10/2004

Patent Number: Not Issued **Issue Date:** N/A **Date of Abandonment:** N/A

Confirmation Number:5025 **PALM Location:**

Examiner: 73858 LEBENTRITT, MICHAEL Assignment Data **Group Art**

Unit:2824 **Class/Subclass:**438/685.000

State or Country:IDAHO **Sheets/Drawing:**4 **Total Claims:**20

Independent Claims:2

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Attorneys: ALL **Attorney Docket No:**3264.6US (92-0280.09/US)

Interference No: **Lost Case:**No **Unmatched Petition:**No **L&R Code:**1

Application Number	Application No.	Applicant(s)
	10/637,108	SANDHU ET AL.

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